## WHAT IS CLAIMED IS:

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1. A method for determining properties of a sample surface using an atomic force microscope, comprising:

applying a first voltage between the sample and a probe;

moving the probe towards the surface of the sample;
stopping movement of the probe towards the surface of
the sample when current in the probe is initially detected;
and

applying a magnetic field to the probe such that the probe obtains stable contact with the surface of the sample.

- 2. The method of claim 1, wherein the magnetic field is applied by a magnetic coil.
  - 3. The method of claim 1, wherein the probe is moved towards the sample by a piezoelectric scanner.
- 20 4. The method of claim 1, further comprising: converting the current in the probe to a second voltage.
  - 5. The method of claim 4, further comprising: YOR920030276US1 (8728-633) -11-

amplifying the second voltage; and generating an image representative of a sample surface property based on the amplified second voltage.

- 6. The method of claim 1, wherein the magnetic field is applied to the probe after the movement of the probe towards the sample surface is stopped.
  - 7. The method of claim 1, further comprising: oscillating the magnetic field applied to the probe.
    - 8. The method of claim 7, wherein the probe is oscillated with an amplitude of 200 Oe and a frequency of 5 Hz for a duration of 2 cycles.

9. An atomic force microscope that determines characteristics of a surface of a specimen, comprising:

means for applying a first voltage between the sample and the probe;

means for moving the probe towards the surface of the sample;

means for stopping movement of the probe towards the surface of the sample when current in the probe is initially detected; and

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means for applying a magnetic field to the probe such that the probe obtains stable contact with the surface of the sample.

- 5 10. The atomic force microscope of claim 9, wherein the means for applying a magnetic field is a magnetic coil.
  - 11. The atomic force microscope of claim 9, wherein the means for moving the probe towards the sample is a piezoelectric scanner.
  - 12. The atomic force microscope of claim 9, further comprising:

means for converting the current in the probe to a second voltage.

13. The atomic force microscope of claim 12, further comprising:

means for amplifying the second voltage; and

means for generating an image representative of a

sample surface property based on the amplified second

voltage.

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- 14. The atomic force microscope of claim 9, wherein the means for applying a magnetic field applies a magnetic field to the probe after the means for stopping movement of the probe stops movement of the probe towards the sample surface.
- 15. The atomic force microscope of claim 9, further comprising:

means for oscillating the magnetic field applied to the probe.

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- 16. The atomic force microscope of claim 15, wherein the means for oscillating the probe oscillates the probe with an amplitude of 200 Oe and a frequency of 5 Hz for a duration of 2 cycles.
- 17. The atomic force microscope of claim 9, further comprising a means for supporting the sample, the means for applying a magnetic field being disposed on the means for supporting the sample.